

	<b>Title</b>	<b>Current OR</b>
<b>1</b>	<b>Single self-aligned carbon containing tips</b>	<b>445/24</b>
<b>2</b>	<b>Device comprising carbon nanotube field emitter structure and process for forming device</b>	<b>313/311</b>
<b>3</b>	<b>Field emitter with wide band gap emission areas and method of using</b>	<b>313/309</b>
<b>4</b>	<b>Process and structure of an integrated vacuum microelectronic device</b>	<b>313/309</b>
<b>5</b>	<b>Fabrication process for direct electron injection field-emission display device</b>	<b>445/24</b>
<b>6</b>	<b>Selectively shaped field emission electron beam source, and phosphor array for use therewith</b>	<b>313/495</b>
<b>7</b>	<b>Method for making tapered microminiature silicon structures</b>	<b>216/11</b>
<b>8</b>	<b>Structures and processes for fabricating field emission cathodes</b>	<b>445/24</b>

	<b>Current XRef</b>
<b>1</b>	<b>313/309; 313/311</b>
<b>2</b>	<b>313/309; 313/310; 313/495; 445/49; 445/50; 445/51</b>
<b>3</b>	<b>257/77; 313/355; 445/50</b>
<b>4</b>	<b>445/50</b>
<b>5</b>	<b>313/496</b>
<b>6</b>	<b>313/309; 313/310; 313/336; 313/351; 313/466; 313/496; 445/50</b>
<b>7</b>	<b>216/41; 216/79; 313/366; 445/24</b>
<b>8</b>	<b>313/336; 445/50</b>

	<b>Title</b>	<b>Current OR</b>
<b>1</b>	<b>Carbon fiber-based field emission devices</b>	<b>313/309</b>
<b>2</b>	<b>Electron emitter device for data storage applications and method of manufacture</b>	<b>361/225</b>
<b>3</b>	<b>Device for emitting electrons</b>	<b>313/311</b>
<b>4</b>	<b>Carbon fiber-based field emission devices</b>	<b>313/311</b>
<b>5</b>	<b>Processing of materials for uniform field emission</b>	<b>445/6</b>
<b>6</b>	<b>Energetic-electron emitters</b>	<b>315/169.1</b>

	<b>Current XRef</b>	<b>Retrieval Classif</b>
<b>1</b>	<b>313/311</b>	
<b>2</b>		
<b>3</b>	<b>313/309; 313/310; 313/336; 313/351</b>	
<b>4</b>	<b>313/346R; 313/495</b>	
<b>5</b>	<b>427/540; 445/51</b>	
<b>6</b>	<b>257/77; 313/310; 313/311; 313/496; 315/169.3</b>	